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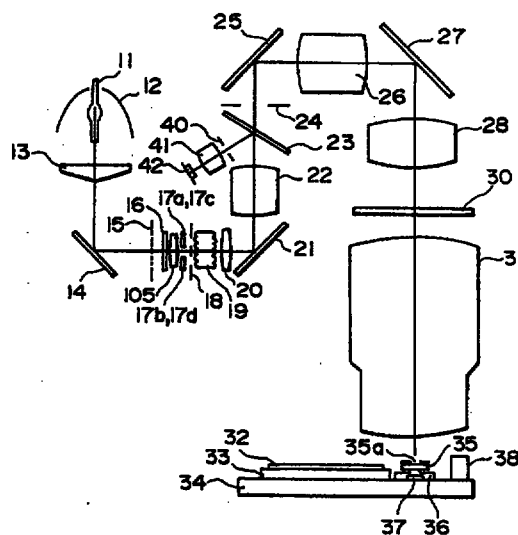
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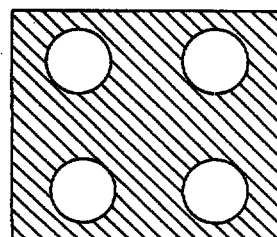
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⑤④ Imaging method for manufacture of microdevices.

⑤⑦ An imaging method for imaging a fine pattern having linear features extending along orthogonal first and second directions, is disclosed which method is characterized by: providing a light source having decreased intensity portions at a center thereof and on first and second axes defined to intersect with each other at the center and defined along the first and second directions, respectively; and illuminating the pattern with light from the light source.



**FIG. 6A**



**FIG. 6B**

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